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06/23/2011

Docket No. F-9089

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JUN 09 2011****RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1795****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Joachim MAI, et al.
Serial No. : 10/578,047
Filed : August 7, 2007
For : METHOD AND DEVICE FOR ION BEAM
PROCESSING OF SURFACES
Group Art Unit : 1724
Examiner : Rodney Glenn McDonald
Confirmation No. : 5426
Customer No. : 000028107

Certificate of Facsimile Transmission Under 37 CFR 1.8

I hereby certify that this correspondence is being transmitted in accordance with 37 CFR §1.6(d) to the United States Patent Office addressed to COMMISSIONER FOR PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450 on June 9, 2011 to facsimile no. (571) 273-8300.

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C. Bruce Hamburg
(Name)


(Signature)

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116

Sir:

In response to the final Office Action of April 20, 2011 entry of the present amendment effecting claim amendments to place the application in condition for

F9089 Andm AF 6-2011 (PC10).wpd

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Ser. No. 10/578,047

allowance or remove issues from appeal, if required, is respectfully requested. Please
amend the above-identified patent application as follows: